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(Week)	(Course Contents)	(Etc.)	
1	Introduction and Historical Perspective		
2	Modern CMOS Technology		
3	CMOS Process Flow		
4	Fabrication and Basic Properties of Silicon Wafers		
5	Clean Rooms, Wafer Cleaning, and Gettering		
6	Lithography		
7	Thermal Oxidation and the Si/SiO ₂ Interface		
8			

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(Week)	(Course Contents)	(Etc.)	
9	Dopant Diffusion		
10	Ion Implantation		
11	Thin Film Deposition I		
12	Thin Film Deposition II		
13	Etching		
14	Team Project Presentation		
15	Interconnect		
16			

<p style="text-align: center;">가 1 (Additional Guide1)</p>	<p style="text-align: center;">()</p> <p>Students who require special assistance (including special needs students) may contact their professors during the first week of the semester to discuss issues related to attendance, lectures, assignments and exams and request learning assistance.</p>
<p style="text-align: center;">가 2 (Additional Guide2)</p>	<p style="text-align: center;">가</p> <p>o - '0' - term paper 'F' o o o o ()</p>